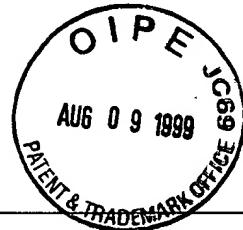


(PP 28PF)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: Application of Cerni et al.  
Serial No.: 09/296,928  
Filed: April 22, 1999  
For: CHEMICAL MECHANICAL  
PLANARIZATION (CMP) SLURRY  
QUALITY CONTROL PROCESS AND  
PARTICLE SIZE DISTRIBUTION  
MEASURING SYSTEMS

Examiner: Not Assigned  
Group Art Unit: 2877  
Docket No.: 7009/018CP



CERTIFICATE OF MAILING (37 CFR 1.8)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231.

Date July 29, 1999

Nancy Halas  
Nancy Halas

Assistant Commissioner for Patents  
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Pursuant to 37 CFR §1.97(c) and the duty of disclosure under 37 CFR §1.56, Applicant(s) submit the enclosed references and Form 1449 for consideration in the above-identified application.

The undersigned attorney believes that no fees are due, but authorizes the Commissioner to charge any additionally required fees to Deposit Account No. 04-1697.

Respectfully submitted,  
DUFT, GRAZIANO, & FOREST, P.C.

By: Curtis A. Vock

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Date: 29 July 1999

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